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#4 1763
PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of

Jennifer Sun et al.

Application No.: 10/075,967

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For: YTTRIUM OXIDE BASED SURFACE
COATING FOR SEMICONDUCTOR
IC PROCESSING VACUUM
CHAMBERS

Group Art Unit: 1763

Confirmation No. 9245

Examiner: Unknow

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